



中国科学院高能物理研究所
Institute of High Energy Physics
Chinese Academy of Sciences



DRD3

Low Gain Avalanche Detectors with deep Carbon implantation

Yuan Feng

Institute of High Energy Physics, Chinese Academy of Sciences (IHEP,CAS)

WG3/WP3 - Extreme fluence and radiation damage characterization

Motivation

- Low gain avalanche detectors with 30ps temporal resolution designed by IHEP are chosen as a part of HGTD for HL-LHC. These detectors (denoted as W0) are:
 - Carbonated.
 - Different implantation depth for gain layer and Carbon.
 - High thermal load for Carbon.
- Growing need for enhanced radiation hardness in detectors:
 - to meet higher requirements, we have investigated devices utilizing a deep carbon implantation layer.

Table 7.1: Key numbers relating the detector challenges at the different accelerators.

Parameter	Unit	LHC	HL-LHC	HE-LHC	FCC-hh
Total number of pp collisions	10^{10}	2.6	26	91	324
Charged part. flux at 2.5 cm, est.(FLUKA)	GHz cm^{-2}	0.1	0.7	2.7	8.4 (10)
1 MeV-neq fluence at 2.5 cm, est.(FLUKA)	10^{16} cm^{-2}	0.4	3.9	16.8	84.3 (60)
Total ionising dose at 2.5 cm, est.(FLUKA)	MGy	1.3	13	54	270 (300)
$dE/d\eta _{\eta=5}$ [331]	GeV	316	316	427	765
$dP/d\eta _{\eta=5}$	kW	0.04	0.2	1.0	4.0
90% $b\bar{b}$ $p_T^b > 30 \text{ GeV}/c$ [332]	$ \eta <$	3	3	3.3	4.5
VBF jet peak [332]	$ \eta $	3.4	3.4	3.7	4.4
90% VBF jets [332]	$ \eta <$	4.5	4.5	5.0	6.0
90% $H \rightarrow 4l$ [332]	$ \eta <$	3.8	3.8	4.1	4.8

Roadmap of IHEP sensors

IHEP_IMEv1
2020

IHEP_IMEv2
2021-2022

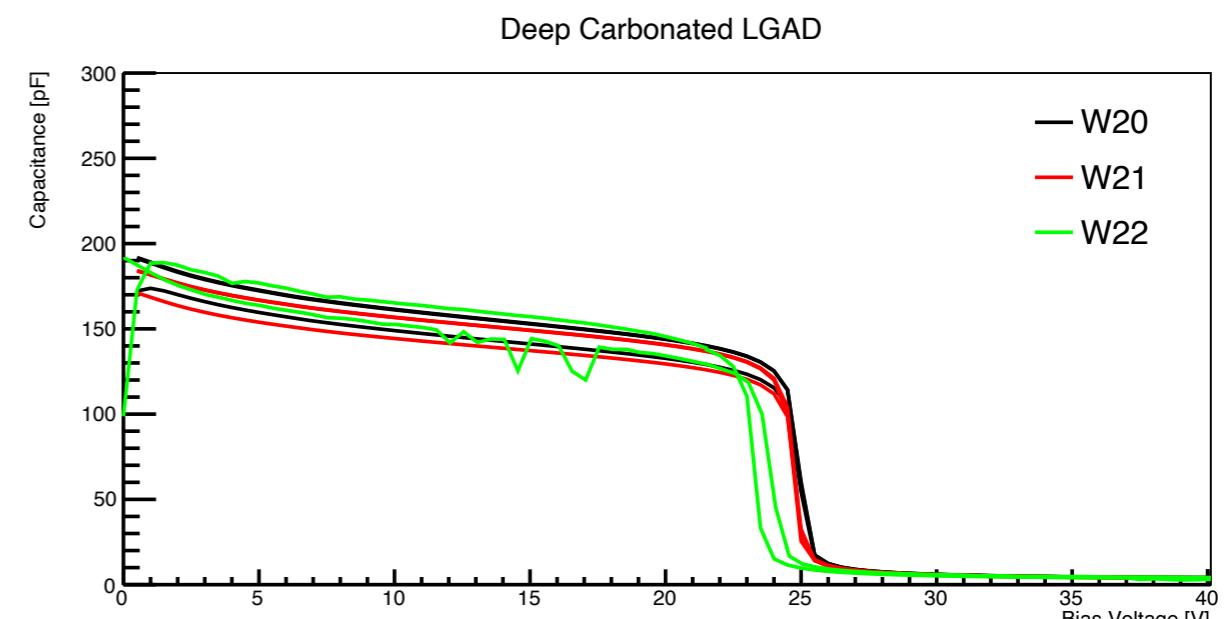
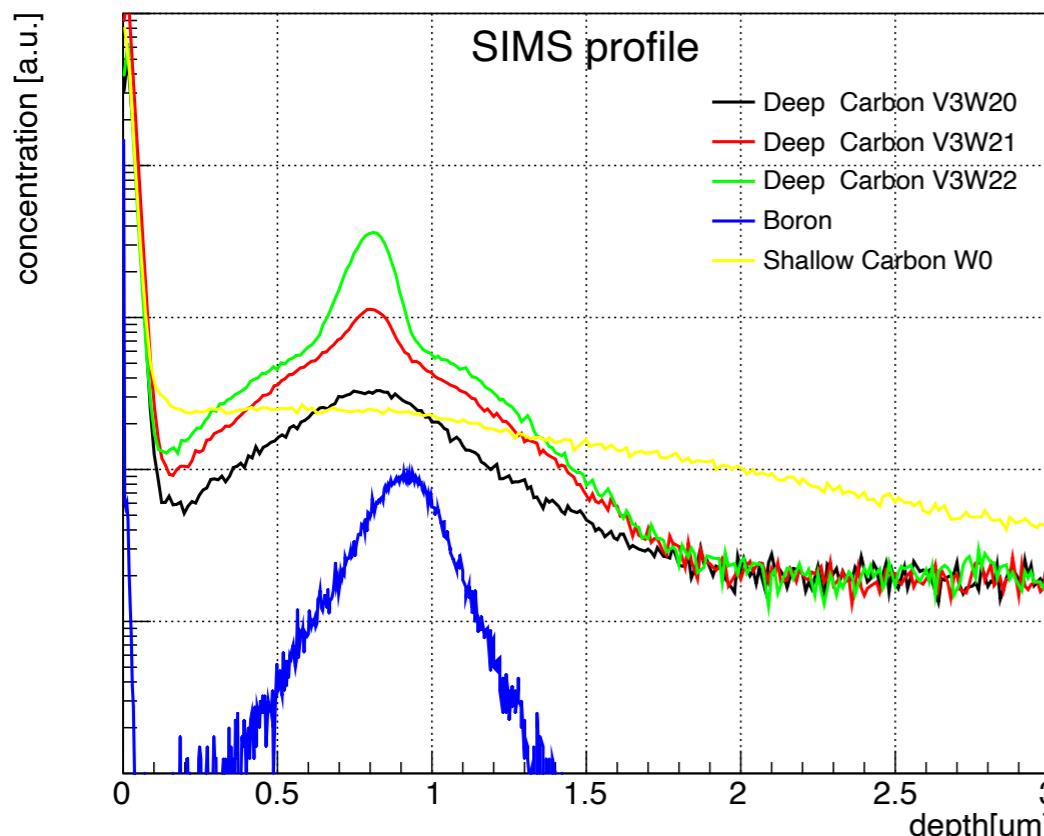
IHEP_IMEv3
2022-

IHEP_IMEv3 LGAD designs

Sensor	Diffuse	C dose(a.u.)	
W15	CHBL	0.5	Different B dose
W16 W17	CHBL	0.2	Interpolate v2w7 to minimize the C factor.
W16Q1		0.3	
W16Q2		0.4	
W16Q3		0.5	
W16Q4		0.6	
W17Q1		0.7	
W17Q2		0.8	
W17Q3		0.9	
W17Q4			
W18	CMBL	0.5, 0.8, 1, 2	Change c thermal load
W20 w21 w22	CHBL	0.2	Different C Depth
	CHBL	0.5	
	CHBL	1	



Doping profiles and V_{gl}



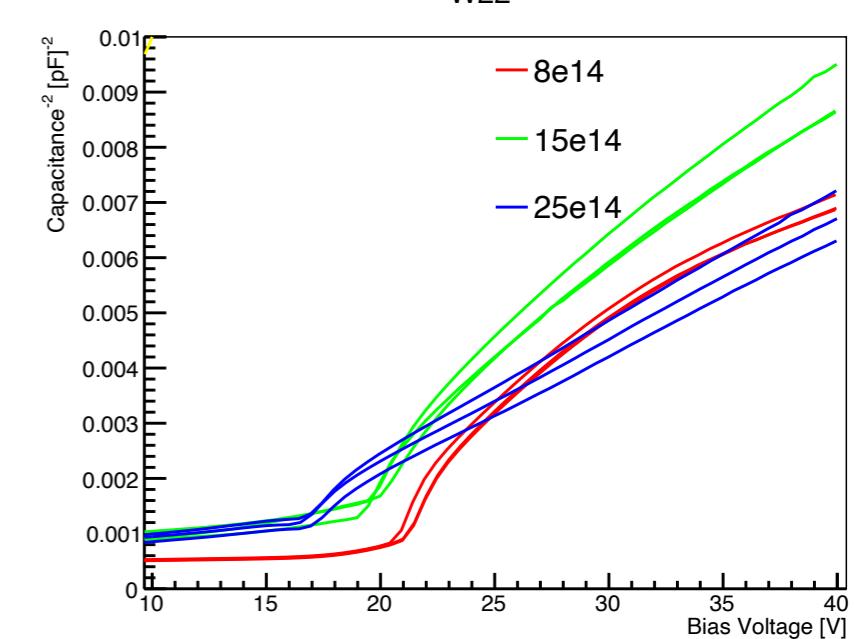
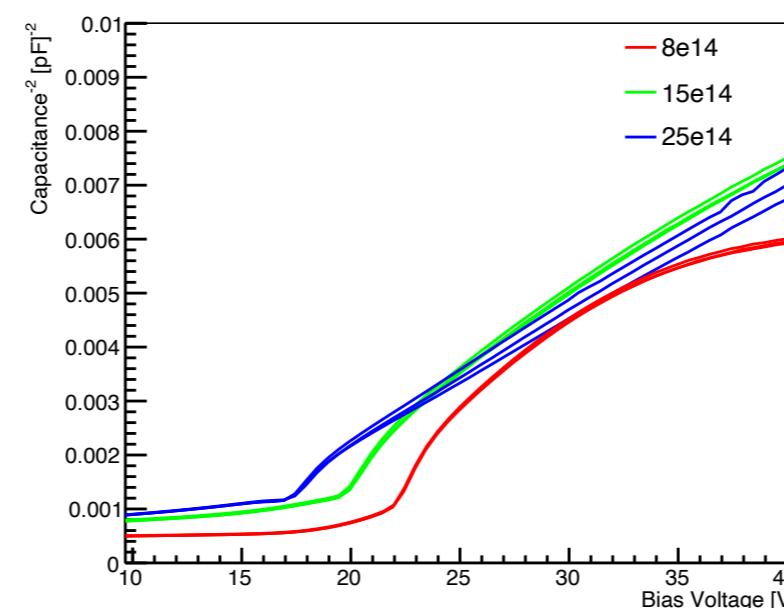
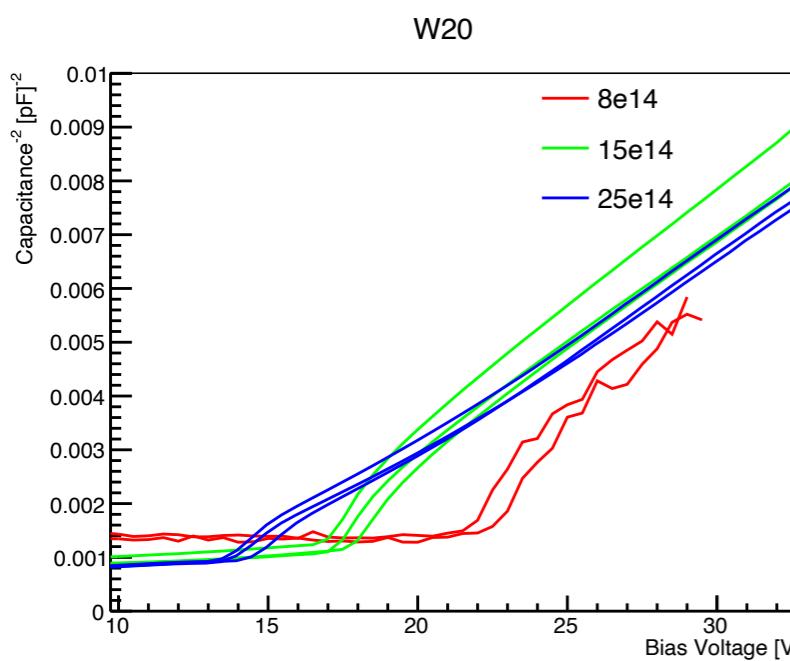
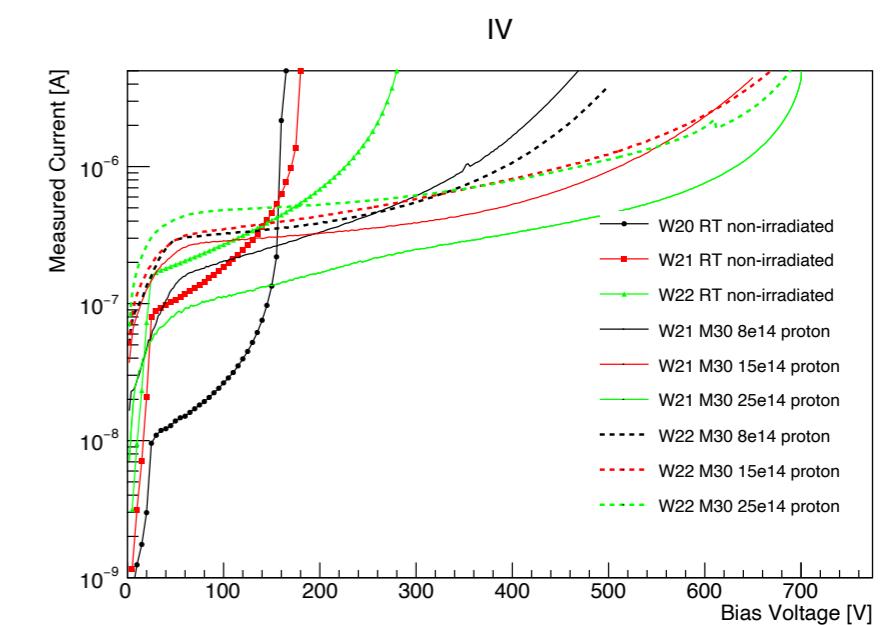
Wafer	W20	W21	W22
V _{gl} (V)	24.8	24.6 (-0.8%)	23.3 (-6%)

- Carbon and Boron are implanted with very close depth.
- 3 deep carbonated wafers differ only in carbon dose.
- Gain layer deactivated with increasing carbon density, up to 6%.

Radiation resistance 1

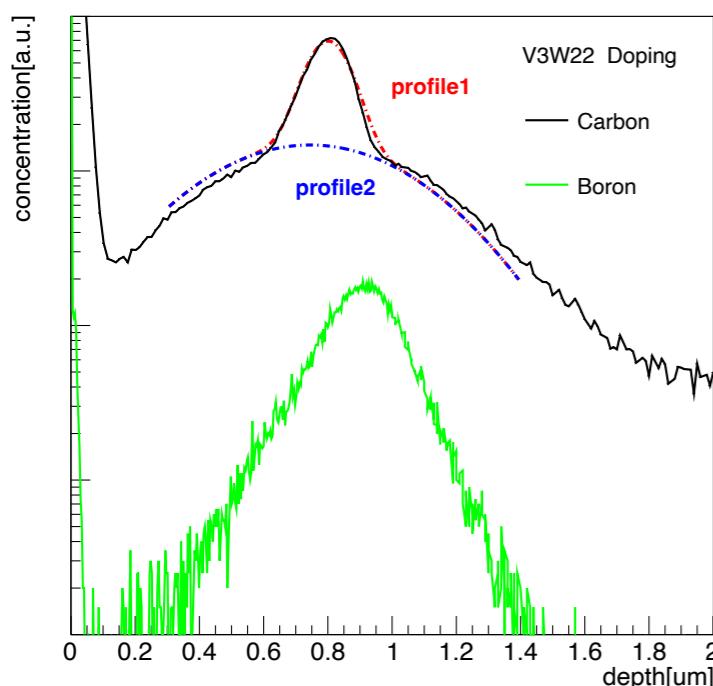
- 80MeV proton irradiation at China Spallation Neutron Source (csns) up to $2.5e15 \text{ } n_{eq}/cm^2$.
- Measure c-factor with CV scan.

Wafer	W20	W21	W22	W0
C ($1e-16\text{cm}^2$) proton	2.48	1.63	1.44	3.11
C ($1e-16\text{cm}^2$) neutron (JSI)	-	-	-	1.06

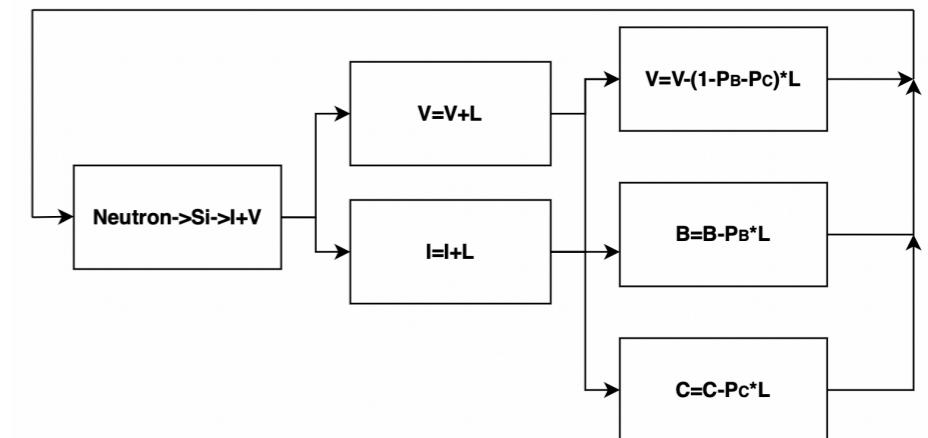


Radiation resistance 2

- Modeling c factors
 - 1. Assume carbon with **profile1** protects boron.
 - 2. Only carbon with **profile 2** affects.



Wafer	W20	W21	W22	W0
C (1e-16cm ²) proton	2.48	1.63	1.44	3.11
C (1e-16cm ²) netron	-	-	-	1.06
C (neutron) Assumption 1	1.18	0.74	0.50	-
C (neutron) Assumption 2		0.82	0.70	-
Ratio (proton / neutron)	2.10	2.20	2.88	2.93
		1.99	2.06	

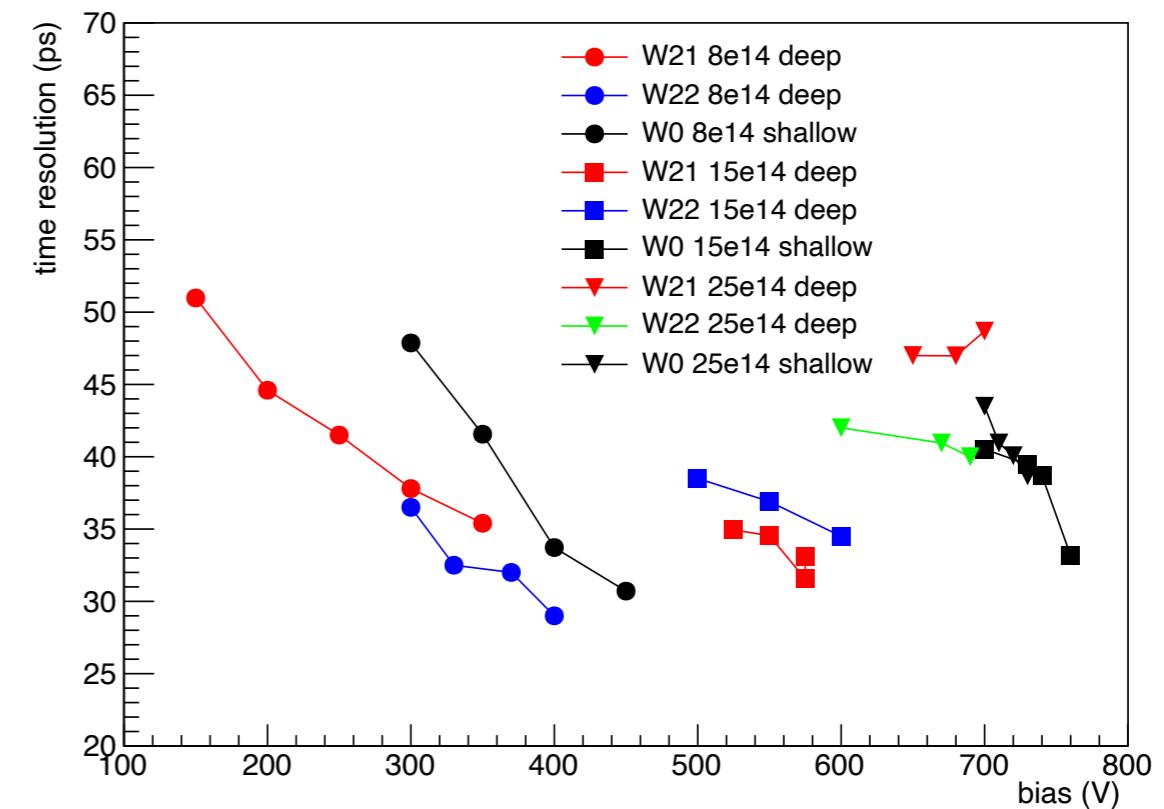
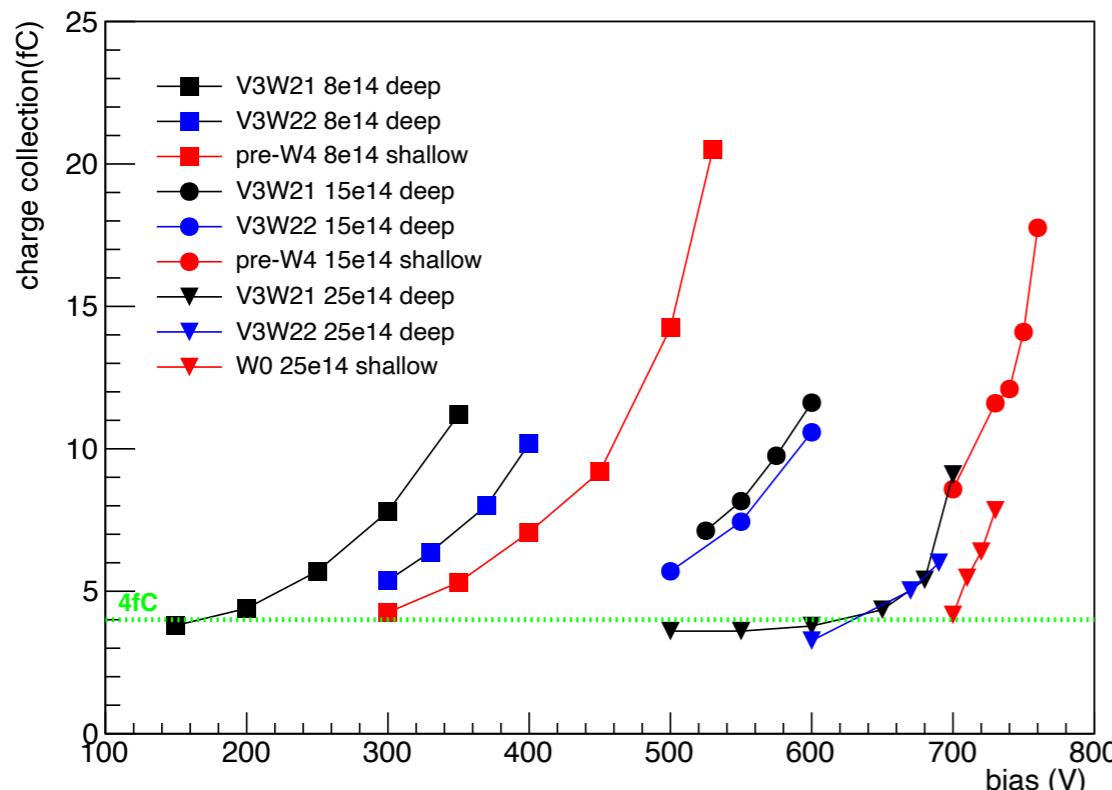


A simple monte carlo scheme

- Ratio of proton c-factor and neutron c-factor derived from modeling: between 2 and 3.
- Improvement in radiation hardness compared with shallow carbonated LGAD (W0).

Radiation resistance 3

- Charge collection and time resolution:
 - A comparison with pre-W4, both much improvement especially at lower irradiation dose.
 - W22 shows slightly smaller c value, it's charge collection is not better than W21.



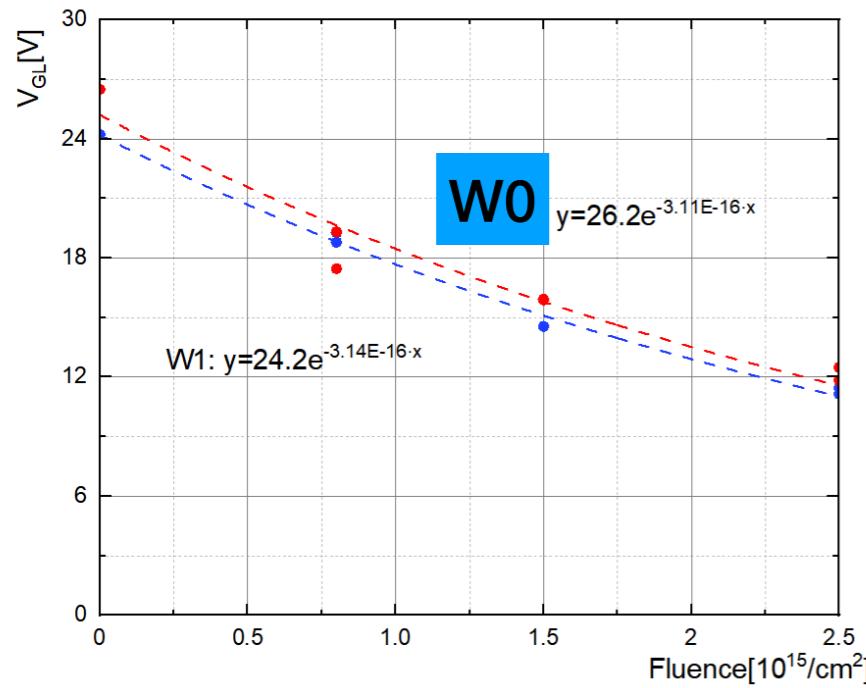
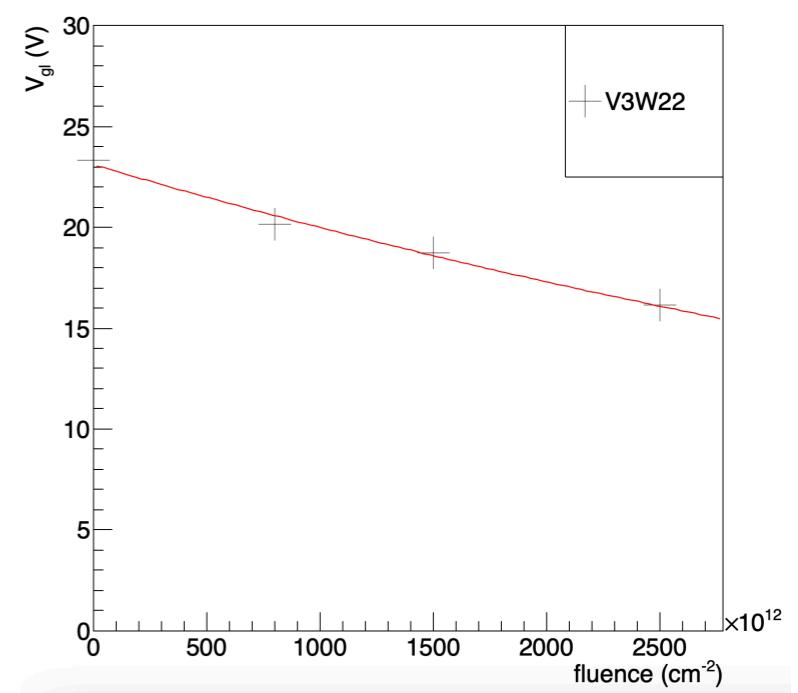
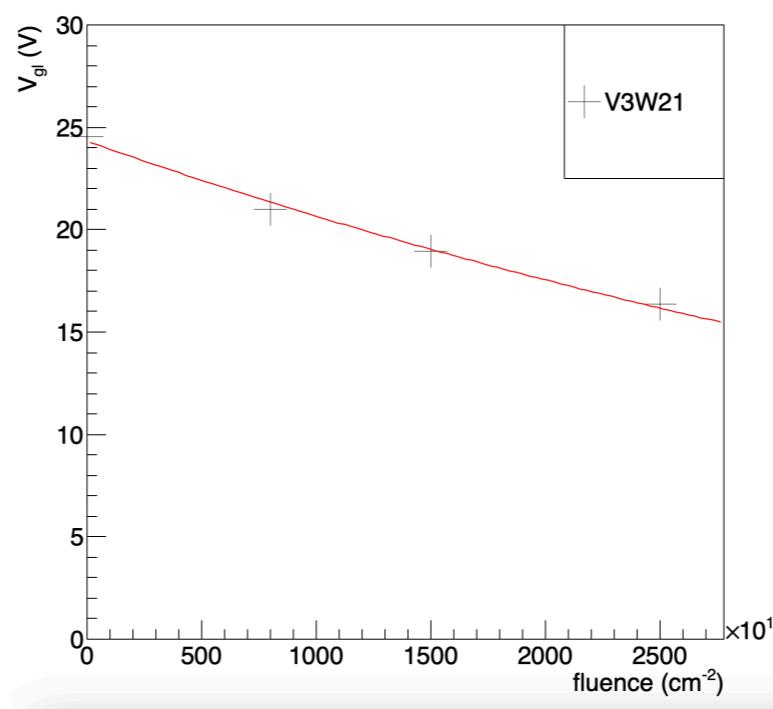
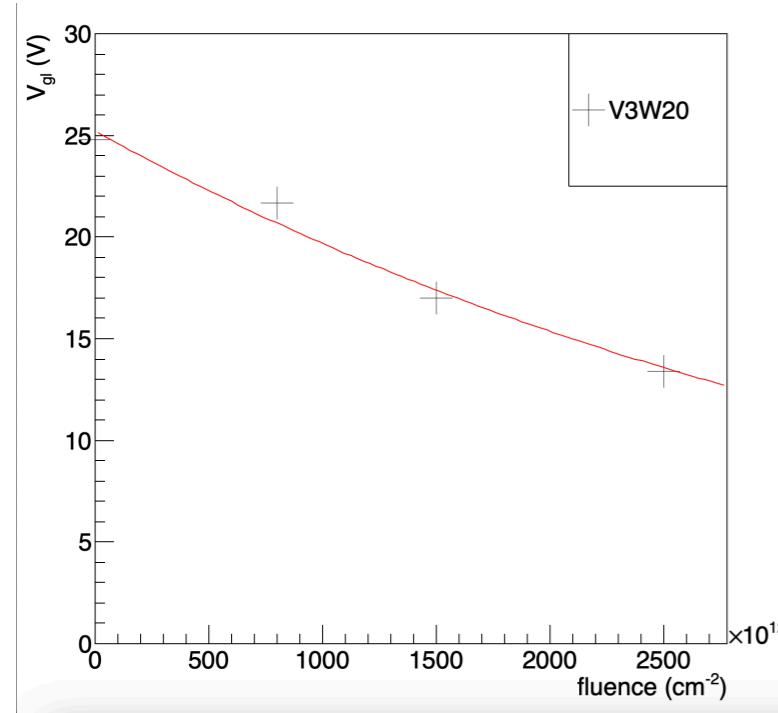


Summary

- LGAD devices with Boron and Carbon implanted with same depth is designed by IHEP.
 - Common features:
 - All wafers utilize the same gain layer design.
 - The carbon annealing process involves a high thermal load to create a wide active profile.
 - Among all recipes with different Carbon energy and dose, the deep-implanted design with moderate dose exhibits best performance.
 - Challenges:
 - The carbon profile is limited by anneal temperature.
 - Gain layer acceptors become deactivated as carbon density increases.
 - High leakage current are inevitable issue worsening with gain layer carbon density.



- CV curve

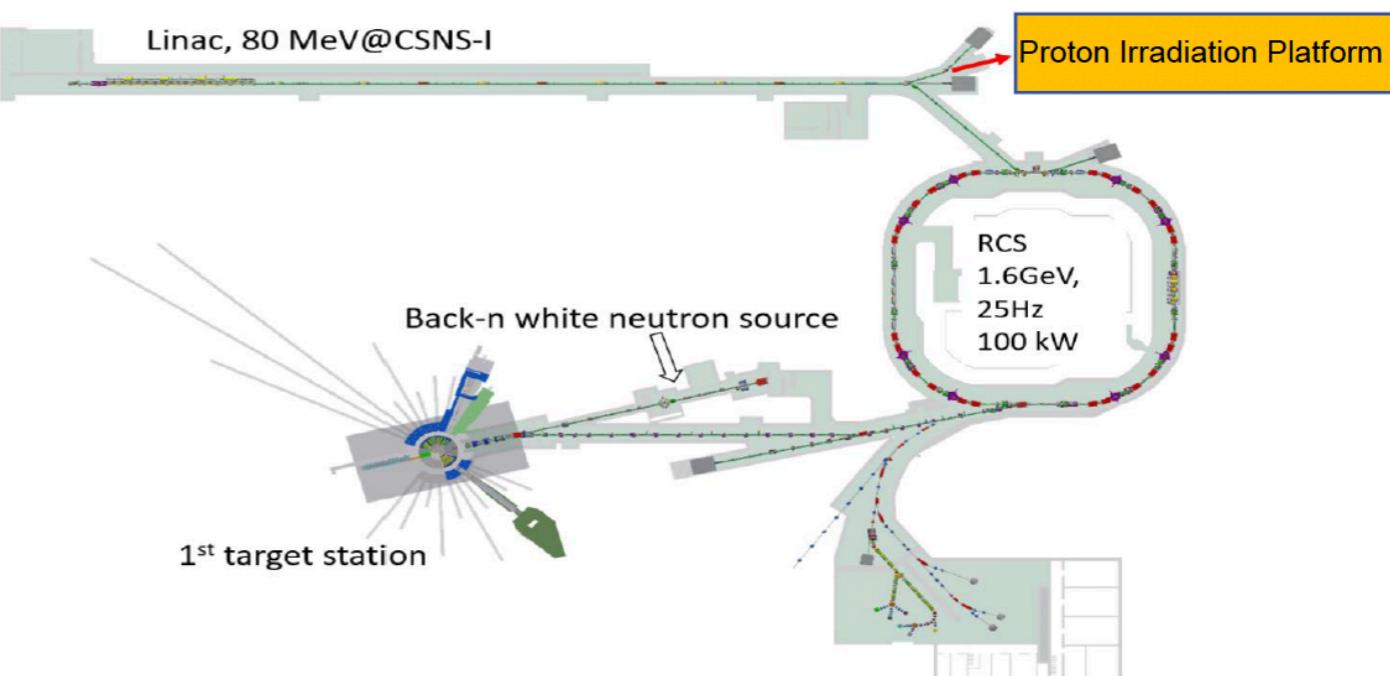




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About CSNS



Facility	Proton energy (MeV)	Proton flux ($p \cdot cm^{-2} \cdot s^{-1}$)	Beam spot size (cm)
CSNS APEP	10 — 80	$10^7 — 10^{10}$	1×1 — 5×5

- Beam Energy: 80MeV
- Beam Size: $20 \times 20 mm^2$



Irradiation setup

